# SIMULATED LORENTZ FORCE DETUNING COMPENSATION WITH A DOUBLE LEVER TUNER ON A DREASSED ILC/1.3 GHz CAVITY AT ROOM TEMPERATURE

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# Introduction

- Pulsed SRF linacs with high accelerating gradients experience large frequency shifts caused by Lorentz force detuning (LFD)
- A piezoelectric actuator with a resonance control algorithm can maintain the cavity frequency at the nominal level thus reducing the RF power.
- This study uses a double lever tuner (LCLS-II type) with a piezoelectric actuator for compensation and another piezoelectric actuator to simulate the effects of the Lorentz force pulse, see Fig. 1
- A double lever tuner has an advantage by increasing the stiffness of the cavity-tuner system thus reducing the effects of LFD. The tests are conducted at room temperature and with a dressed 1.3 GHz 9-cell cavity



# **Experimental Setup**

Figure 1: Setup of LFD simulation with 1.3 GHz cavity. The Two piezo capsules are used for resonance control and a piezo (denoted as shaker) is used to simulate the LFD.



control.

- hardware topology frequency resonance shown in Fig. 2.
- the  $\pi$ at room temperature.
- coupled (APD) .
- The transmitted power input B of APD. power

The phase of the forward and transmitted power can then be related to the cavity detuning. This was digitized with NI-PXI-4472 14-bit ADC.

the signal and the cavity and for control is

An RF analog signal generator is used to produce the input signal to excite the cavity in mode which occurs at 1298.838 MHz

forward power through а directional coupler is fed to input A of the AD8032 Analog Phase Detector

of the cavity is sent to

The output signal of the APD is proportional to the phase shift between forward and transmitted



Figure 5: 160 Hz single cycle sine wave and the cavity detuning response.

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#### **LFD Resonance Control**

The simulated LFD pulse is done with a square wave pulse on the shaker piezo as shown in

The voltage on the shaker piezo was ~ 70 V

The rise time is 1.2 ms and the flat-top is 0.8 ms

The LFD during the flat-top is ~1.5 kHz

• The goal of the LFD resonance control to decrease the detuning to 0 Hz

This was done by using a sine wave with a frequency which will cause destructive interference with the LFD pulse

Three parameters need to be optimized for the sine wave: the frequency, the amplitude, and the delay from the flat-top

These three parameters were changed by brute force on LabVIEW

• The right frequency can found by taking the FFT of the step response from Fig. 3, the result is shown in Fig 4.

The largest frequencies excited are 175 Hz and 231 Hz

When both these frequencies were implemented the results were not good. The amplitude and delay were also changed

A sine wave of 160 Hz resulted in a flat detuning line



Figure 6: Control pulse which results in a flat cavity detuning. A sine wave of 160 Hz with a delay of 7 ms was used.



Figure 7: Comparison of cavity detuning with piezo control on and off. The results show that when the LFD pulse is compensated the cavity detuning is decreased by a factor of 10.

- A sine wave was used to cause destructive interference with the resulting detuning from the simulated LFD pulse.
- The results show that the detuning is decreased from 1.4 kHz to 140 Hz
- produce results where the detuning is set to 0 Hz



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#### Results

# Conclusion

A double lever tuner was used for LFD resonance control

• Further studies are planned to make the program automatic and



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- The single cycle sine wave was delayed by 7 ms from the LFD pulse. This delay produced the best results.
  - The optimal voltage for the control piezo was 35 V peak-to-peak.
  - The detuning at the flattop dropped from 1.4 kHz to 140 Hz. The detuning was reduced by a factor of 10.
  - Note the that compensated detuning is not at 0 Hz detuning
  - This was likely due to not optimizing offset the voltage the piezo ot control
  - In future iterations this will also need to be optimized.